

Sheet 1 of 1

Form PTO-1449 (REV. 8-83)		US Dept. of Commerce PATENT & TRADEMARK OFFICE		ATTY DOCKET NO. 110157.99		APPLICATION NO. 08/994,758	
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)				APPLICANT Kenji NISHI			
				FILING DATE December 19, 1997		GROUP 2851	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	
AM		5,506,684	4/1996	OTA et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	
AM		JP A-4-196513 (w/abstract)	7-1992	Japan			
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)							
AM		Buckley et al., "Step and scan: A systems overview of a new lithography tool", SPIE Vol. 1088 Optical/Laser					
		Microlithography II (1989), p. 424-433.					
EXAMINER <i>Alan Mathews</i>				DATE CONSIDERED <i>12-7-2001</i>			
Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							